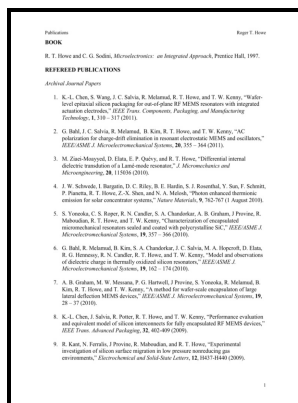


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The output at full-scale applied pressure is a few millivolts per volt of bridge excitation the supply voltage to the bridge. Chengkuo Lee, MOEMS Variable Optical Attenuator with Robust Design for Improved Dynamic Characteristics, IEEE Photon. Protective overlayer material and electro-optical coating using same 1995-07-27 1999-01-19 Regents Of The University Of California Process for forming silicon carbide films and microcomponents 1995-09-14 1998-03-31 Kabushiki Kaisha Toshiba Semiconductor device and manufacturing method therefor 1995-09-14 1997-04-22 Liberkowski; Janusz B.

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It has been successfully used to make micromechanical structures and to integrate electrical interconnects, thermocouples, p-n junction diodes, and many other electrical devices with micromechanical structures.

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Group of Chengkuo Lee

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